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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10016610	FILING DATE 10/30/2001	CLASS 414	SUBCLASS 273	GAU 3652	EXAMINER Gallie
**APPLICANTS: McGowan Richard;					
**CONTINUING DATA VERIFIED: <i>none</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>none</i>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO			
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		SC0251WD			
Verified and Acknowledged Examiners's initials <i>[Signature]</i>					
TITLE : Wafer management system and methods for managing wafers					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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